OIPE JC179 JAN 07 2004 PATENT & TRADEMARK OFFICE

Form PTO-1449 (Rev. 6-98)
U.S. Department of Commerce
Patent and Trademark Office

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Attorney Docket No.	Serial No.
75252-022	10/678,253
Applicant	
David L. Johnson et al.	
Filing Date	**Group Art Unit**
October 3, 2003	Not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation
SM	2002/0160309	10/31/2002	Pang et al.			
	2002/0106584	08/08/2002	Lawton et al.			
	2002/0081505	06/27/2002	Lawton et al.			
	2001/0046642	11/29/2001	Johnson et al.			
	6,537,729	03/25/2003	Lawton			
	6,413,697	07/02/2002	Melisaris et al.			
	6,365,644	04/02/2002	Yamamura et al.			
	6,379,866	04/30/2002	Lawton et al.			
	6,287,748	09/11/2001	Lawton			
	6,287,745	09/11/2001	Yamamura et al.			
	6,127,085	10/03/2000	Yamamura et al.			
	6,096,796	08/01/2000	Watanabe et al.			
	6,063,888	05/16/2000	Yamaguchi et al.			
	6,013,749	01/11/2000	Baba et al.			
	6,013,714	01/11/2000	Haruta et al.			
	5,986,018	11/16/1999	Yamaguchi et al.			
	5,981,616	11/09/1999	Yamamura et al.			
	5,972,563	10/26/1999	Steinmann et al.			
SM	5,932,625	08/03/1999	Watanabe et al.			

Examiner [signature] Date Considered 1/17/06

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Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation
SMC	6,376,571	04/23/2002	Chawla et al.			
	6,362,249	03/26/2002	Chawla			
	6,355,599	03/12/2002	Zahora et al.			
	6,340,297	01/22/2002	Chapman et al.			
	6,306,924	10/23/2001	Szum			
	6,174,156	01/16/2001	Chapman et al.			
	6,087,533	07/11/2000	Burke			
	6,021,338	02/01/2000	Zahora et al.			
	5,707,780	01/13/1998	Lawston et al.			
	5,664,041	09/02/1997	Szum			
	5,639,413	06/17/1997	Crivello			
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	5,463,084	10/31/1995	Crivello et al.			
SMC	5,461,088	10/24/1995	Wolf et al.			

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SMC	5,456,984	10/10/1995	Bishop et al.			
	5,384,342	01/24/1995	Szum			
	5,336,563	08/09/1994	Coady et al.			
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	5,002,854	03/26/1991	Fan et al.			
	4,942,066	07/17/1990	Fan et al.			
	4,942,060	07/17/1990	Grossa			
	4,853,434	08/01/1989	Block			
SMC	3,708,296	01/02/1973	Schlesinger			

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Examiner Initial	Document Number	Date	Country	Class	Sub Class	Translation
SMC	EP 0646580	4/ 5/1995	EPO			No
	English Abstract of EP 0646580	4/ 5/ 1995	EPO			Yes
	EP 0360869	4/ 4/1990	EPO			Yes
	EP 0162304	11/27/1985	EPO			Yes
SMC	JP 02 75618	3/15/1990	JPO			No

Examiner: SMC McClendon — Date Considered 1/17/04

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Examiner Initial	Document Number	Date	Name	Class	Sub Class	Translation

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Sub Class	Translation
SMC	Translation of JP 0275618	3/15/1990	JPO			Yes

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

SMC	Paul F. Jacobs, Stereolithography and Other RP&M Technologies 33-35 (ASME Press 1996)
	Christian Decker & Khalil Moussa, Kinetic study of the cationic photopolymerisation of epoxy monomers, 28 J. Polym. Sci, Polym. Chem. 3429-43 (1990)
	J.V. Crivello, "Photoinitiated Cationic Polymerization," UV Curing: Science & Technology, (S. P. Pappas, ed., Technology Marketing Corp. 1978)
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	Paul F. Jacobs, Rapid Prototyping & Manufacturing 69-110 (1992)
	Atsushi Udagawa et al., Physical Properties and Photoreactivity of Cycloaliphatic Epoxy Resins Cured by UV-Induced Cationic Polymerization 23 Polym. J. 1081-1090 (1991)
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SMC	Piotr Penczek et al., Epoxypolyesters as Film-Forming Materials 187 Macromol. Symp. 243-244 (2002)

Examiner	Date Considered 1/17/06

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Examiner Initial	Document Number	Date	Country	Class	Sub Class	Translation

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

SMC	Emmanouil Spyrou, Radiation initiated cationic polymerization with tailor-made polyesters 43 Progress in Organic Coatings 25-31 (2001)
	Ramamurti N. Kumar et al., Application of Real Time FTIR and MAS NMR Spectroscopy to the Characterization of UV/EB Cured Epoxidized Natural Rubber Blends 286 Macromol. Mater. Eng. 598-604 (2001)
	Christian Decker et al., Photoinitiated cationic polymerization of epoxides 50 Polym. Int'l 986-997 (2001)
	C. Decker et al., UV-radiation curing of acrylate/epoxide systems 42 Polymer 5531-5541 (2001)
SMC	Naguib Saleh, Mechanical Properties Under Differing Humidity Conditions & Ageing Characteristics Design for Rapid Manufacturing (March 2003)

Examiner	Date Considered
John McClain	1/17/06

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